

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Tokuhisa OHIWA, et al.) **Prior** Group Art Unit: 2823
)
Div. of Application No.: 09/604,724, filed) **Prior** Examiner: Maldonado, Julio J.
June 28, 2000)
)
Filed: Herewith)
)
For: METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicants bring to the attention of the Examiner the documents listed on the attached PTO-1449. This Information Disclosure Statement is being filed concurrently with the above-referenced divisional application.

The listed documents were previously submitted by Applicants or cited by the Examiner in prior application No. 09/604,724, filed June 28, 2000, upon which Applicants rely for the benefits provided in 35 U.S.C. § 120. Applicants respectfully request that the Examiner consider the listed documents and indicate that they were considered by making appropriate notations on the attached form.

The following is a concise statement of relevance of the non-English language document.

1. Japanese Patent Application No. 6-5592 discloses magnetic film patterning by lifting off a magnetic film, by subjecting a resist film to solvent and applying magnetic force to the magnetic film.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and Applicants determine that the cited documents do not constitute "prior art" under United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such documents.

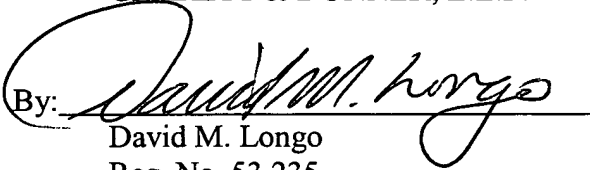
Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: April 15, 2004

By: 
David M. Longo
Reg. No. 53,235

INFORMATION DISCLOSURE CITATION

Atty. Docket No.	04329.2335-01	Div. of Appln. No.	09/604,724
Applicant	Tokuhiwa OHIWA, et al.		
Filing Date	Herewith	Prior Group:	2823

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
	4,434,224	02/1984	Yoshikawa et al.			
	5,185,278	02/1993	Barker			
	5,650,041	07/1997	Gotoh et al.			
	5,976,769	11/1999	Chapman			
	6,251,774 B1	06/2001	Harada et al.			
	6,279,585	08/2000	Shiraki et al.			

FOREIGN PATENT DOCUMENTS

Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
6-5592	01/1994	Japan			Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	Date Considered
<p>*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce